

Docket No.: 2336-213



ZFW
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Inventor(s): Dong Joon KIM et al. : Confirmation No.4032
U.S. Patent Application No. 10/689,629 : Group Art Unit: 1763
Filed: October 22, 2003 : Examiner: GEORGE A GOUDREAU
For: METHOD FOR MANUFACTURING SEMICONDUCTOR LASER DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

01/19/2006 HALI11 00000126 10689629

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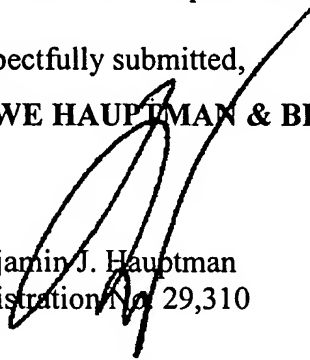
CERTIFICATION PARAGRAPH

The undersigned hereby certifies that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent

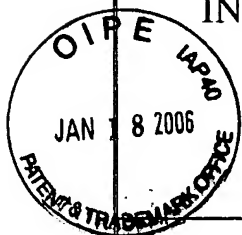
office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement (37 CFR 1.97 (e)(1)).

A credit card authorization form in the amount of \$180.00 is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No. 07-1337.

Respectfully submitted,
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**INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION**
(PTO-1449)

ATTY. DOCKET NO.
2336-213

U.S. PATENT
APPLICATION NO.
10/689,629

APPLICANT
Dong Joon KIM et al.

FILING DATE
October 22, 2003

GROUP
1763

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,445,993	8/1995	Ahn et al			

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	06-69599 (U.S. 5,445,993)	3/1994	Japan				
	04-82291	3/1992	Japan			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.